



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): FUNABASHI  
 Serial No.: 09/902,672  
 Filed: July 12, 2001  
 For: METHOD OF MANUFACTURING A  
 SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE  
 Group: 2825  
 Examiner: L. Malsawma

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 1-6-2002  
 TECHNOLOGY CENTER 2001  
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AMENDMENT

Assistant Commissioner for Patents  
 Washington, D.C. 20231

May 6, 2002

Sir:

In response to the Office Action mailed December 5, 2001, please amend  
 the above-identified application as follows:

IN THE CLAIMS

Please cancel claims 1-16, all of the claims previously considered on the  
 merits in the above-identified application, and substitute therefor the following  
 new claims: